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<u> </u>	Type	Hits	`Search Text	DBs	Time Stamp
1	IS&R	6	(("5461005") or ("5523259") or ("5561083")).PN.	USPAT; US-PGPUB; EPO JPO; DERWENT;	2002/04/08 14:33
2	IS&R	5128	((438/627) or (438/628) or (438/629) or (438/643) or (438/644) or (438/645) or (438/653) or (438/654) or (438/656) or (438/656) or (438/659) or (438/631) or (438/637) or (438/639)).CCLS.	USPAT; US-PGPUB; EPO JPO; DERWENT; IBM_TDB	2002/04/08 14:34
3	BRS	3736	(((438/627) or (438/628) or (438/629) or (438/643) or (438/644) or (438/645) or (438/653) or (438/654) or (438/656) or (438/656) or (438/659) or (438/631) or (438/637) or (438/639)).CCLS.) and @ad<=19980605	JPO; DERWENT;	2002/04/11 08:07
4	BRS	104	((((438/627) or (438/628) or (438/629) or (438/643) or (438/644) or (438/644) or (438/645) or (438/653) or (438/654) or (438/656) or (438/656) or (438/659) or (438/631) or (438/637) or (438/639)).CCLS.) and (@ad<=19980605) and (barrier with (pvd (physical adj vapor adj deposition) sputtering collimating)) and (planarizing cmp (chemical adj mechanical adj (polishing polish)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/04/08 14:41
5	BRS	23	(((((438/627) or (438/628) or (438/629) or (438/643) or (438/644) or (438/645) or (438/653) or (438/654) or (438/656) or (438/663) or (438/597) or (438/598) or (438/631) or (438/637) or (438/639)).CCLS.) and @ad<=19980605) and (barrier with (pvd (physical adj vapor adj deposition) sputtering collimating)) and (planarizing cmp (chemical adj mechanical adj (polishing polish)))) and ((anneal annealing) with barrier)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/04/08 14:44

04/11/2002, EAST Version: 1.03.0002

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2			0
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6	BRS	25	(438/598) Of (436/631) of (438/598) (438/598) CCLS) and @ad<=19980605) and	IBM_TDB	2002/04/08 15:02
, 	BRS	12676	barrier and ((titanium ti) and ((titanium adj nitride)	USPAT; US-PGPUB; EPO; JPO; DERWENT;	2002/04/08 15:03
8	BRS	91	(((((438/627) or (438/628) or (438/629) or (438/643) or (438/644) or (438/645) or (438/653) or (438/654) or (438/656) or (438/653) or (438/654) or (438/656) or (438/653) or (438/598) or (438/631) or (438/637) or (438/639)). CCLS.) and @ad<=19980605) and (barrier with (pvd (physical adj vapor adj deposition) sputtering collimating)) and (planarizing cmp (chemical adj mechanical adj (polishing polish)))) and barrier and ((titanium ti) and	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/04/08 15:04
9	BRS	24	((((((438/627) or (438/628) or (438/629) or (438/643) or (438/644) or (438/645) or (438/653) or (438/654) or (438/656) or (438/656) or (438/656) or (438/656) or (438/6597) or (438/639). (CCLS.) and @ad<=19980605) and (barrier with (pvd (physical adj vapor adj deposition) sputtering collimating)) and (planarizin cmp (chemical adj mechanical adj (polishing polish)))) and ((anneal annealing rta (rapid adj thermal adj annealing)) with barrier)) and barrier	USPAT; US-PGPUB; EPC JPO; DERWENT;); 2002/04/08 15:35

04/11/2002, EAST Version: 1.03.0002

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	Type	Hits		DDS	Time Stamp
10	BRS	17	(((((((438/627) or (438/628) or (438/629) or (438/643) or (438/644) or (438/645) or (438/653) or (438/654) or (438/656) or (438/663) or (438/597) or (438/598) or (438/631) or (438/637) or (438/639)).CCLS.) and @ad<=19980605) and (barrier with (pvd (physical adj vapor ad) deposition) sputtering collimating)) and (planarizing cmp (chemical adj mechanical adj (polishing polish)))) and ((anneal annealing rta (rapid adj thermal adj annealing)) with barrier)) and barrier and ((titanium ti) and ((titanium adj nitride) tin)) and	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/04/08 15:36
11	BRS	22	((((((438/627) or (438/628) or (438/629) or (438/643) or (438/644) or (438/645) or (438/653) or (438/654) or (438/656) or (438/653) or (438/597) or (438/598) or (438/631) or (438/637) or (438/639)).CCLS.) and @ad<=19980605) and (barrier with (pvd (physical adj vapor adj deposition) sputtering collimating)) and (planarizing cmp (chemical adj mechanical adj (polishing polish)))) and ((anneal annealing rta (rapid adj thermal adj annealing)) with barrier) and barrier and ((titanium ti) and ((titanium adj nitride) tin)) and	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/04/08 15:36
12	BRS	16	((((((438/627) or (438/628) or (438/629) or (438/643) or (438/644) or (438/645) or (438/653) or (438/654) or (438/656) or (438/653) or (438/598) or (438/631) or (438/637) or (438/639). CCLS.) and @ad<=19980605) and (barrier with (pvd (physical adj vapor adj deposition) sputtering collimating)) and (planarizing cmp (chemical adj mechanical adj (polishing polish)))) and ((anneal annealing rta (rapid adj thermal adj annealing)) with barrier)) and barrier and ((titanium ti) and ((titanium adj nitride) tin)) and	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/04/08 16:10

04/11/2002, EAST Version: 1.03.0002

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13	BRS	3	((((((((438/627) or (438/628) or (438/629) or (438/643) or (438/644) or (438/645) or (438/653) or (438/654) or (438/656) or (438/663) or (438/597) or (438/598) or (438/631) or (438/637) or (438/639)).CCLS.) and @ad<=19980605) and (barrier with (pvd (physical adj vapor adj deposition) sputtering collimating)) and (planarizing cmp (chemical adj mechanical adj (polishing polish)))) and ((anneal annealing rta (rapid adj thermal adj annealing)) with barrier)) and barrier and ((titanium ti) and ((titanium adj nitride) tin)) and	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/04/08 16:16
14	BRS	15	(((((438/627) or (438/628) or (438/629) or (438/643) or (438/644) or (438/645) or (438/653) or (438/654) or (438/656) or (438/637) or (438/598) or (438/631) or (438/637) or (438/639)). CCLS.) and @ad<=19980605) and (barrier with (pvd (physical adj vapor adj deposition) sputtering collimating)) and (planarizing cmp (chemical adj mechanical adj (polishing polish)))) and (rta (rapid adj thermal adj (anneal	USPAT; US-PGPUB; EPO JPO; DERWENT; IBM_TDB	2002/04/08 16:20
15	BRS	9	(((((438/627) or (438/628) or (438/629) or (438/643) or (438/644) or (438/645) or (438/653) or (438/654) or (438/656) or (438/653) or (438/657) or (438/639) or (438/631) or (438/637) or (438/639)).CCLS.) and @ad<=19980605) and (barrier with (pvd (physical adj vapor adj deposition) sputtering collimating)) and (planarizin cmp (chemical adj mechanical adj (polishing polish)))) and (rta (rapid adj thermal adj (anneal	USPAT; US-PGPUB; EPC JPO; DERWENT; IBM_TDB	; 2002/04/08 16:20
16	BRS	397	((((438/627) or (438/628) or (438/629) or (438/643) or (438/644) or (438/645) or (438/653) or (438/656) or (438/656) or (438/656) or (438/637) or (438/639)).CCLS.) ar (@ad<=19980605) and ((chemical adj mechanical adj polish) cmp)	DUSPAT; US-PGPUB; EPC JPO; DERWENT;); 2002/04/11 08:08

04/11/2002, EAST Version: 1.03.0002

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17	BRS	111	(438/654) or (438/656) or (438/663) or (438/597) or	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/04/11 08:09
18	BRS	17	((((((438/627) or (438/628) or (438/629) or (438/643) or (438/644) or (438/645) or (438/653) or (438/654) or (438/656) or (438/653) or (438/597) or (438/598) or (438/631) or (438/637) or (438/639)).CCLS.) and @ad<=19980605) and ((chemical adj mechanical adj polish) cmp)) and (metal with cmp)) and (barrier with cmp)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/04/11 08:18
19	BRS	17	((((((438/627) or (438/628) or (438/629) or (438/643) or (438/644) or (438/645) or (438/653) or (438/654) or (438/656) or (438/653) or (438/597) or (438/598) or (438/631) or (438/637) or (438/639)).CCLS.) and @ad<=19980605) and ((chemical adj mechanical adj polish) cmp)) and (metal with cmp)) and (barrier with cmp)) and	USPAT; US-PGPUB; EPO JPO; DERWENT; IBM_TDB	2002/04/11 08:18
20	BRS	17	((((((((438/627) or (438/628) or (438/629) or (438/643) or (438/644) or (438/645) or (438/653) or (438/654) or (438/656) or (438/653) or (438/597) or (438/598) or (438/631) or (438/637) or (438/639)).CCLS.) and @ad<=19980605) and ((chemical adj mechanical adj polish) cmp)) and (metal with cmp)) and (barrier with cmp)) and surface) and contact	r 「USPAT; US-PGPUB; EPC JPO; DERWENT; IBM_TDB	2002/04/11 09:45

04/11/2002, EAST Version: 1.03.0002

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17			0
18			0
19			0
20			0